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Docket No.: H6810.0021/P021  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Patent Application of:**  
**Akira Sekine et al.**

**Application No.: 09/858,477**

**Art Unit: 1743**

**Filed: May 17, 2001**

**Examiner: Yelena G. Gakh**

**For: METHOD AND SYSTEM FOR**  
**COMPREHENSIVE MANAGEMENT OF**  
**CHEMICAL MATERIALS**

**AMENDMENT AFTER FINAL REJECTION**

**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

**Dear Sir:**

**INTRODUCTORY COMMENTS**

**In response to the Office Action dated August 25, 2004, please amend the**  
**above-identified U.S. patent application as follows:**

**Amendments to the Claims begin on page 2 of this paper.**

**Remarks/Arguments begin on page 7 of this paper.**